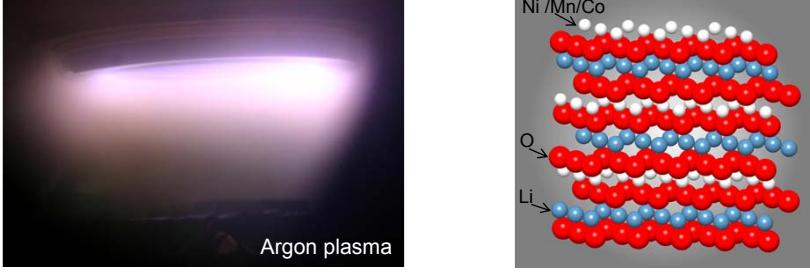


**IAM**  
Institute for Applied Materials

**KIT**  
Karlsruher Institut für Technologie

# Magnetron sputtered Li-Ni-Mn-Co-O thin film cathodes for lithium-ion batteries

**M. Strafela, J. Fischer, H. Leiste, M. Rinke, T. Bergfeldt, S. Ulrich, H.J. Seifert**  
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Institute for Applied Materials – Applied Materials Physics IAM-AWP, Department Composites and Thin Films



Argon plasma

Ni /Mn/Co  
O  
Li



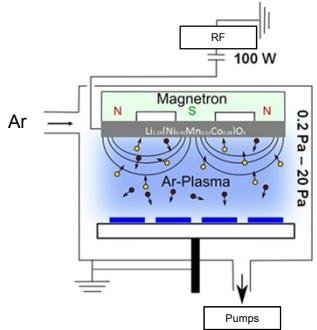
## Outline

Motivation



[www.infinitesolutions.com](http://www.infinitesolutions.com) (2014)

Thin film synthesis & characterisation

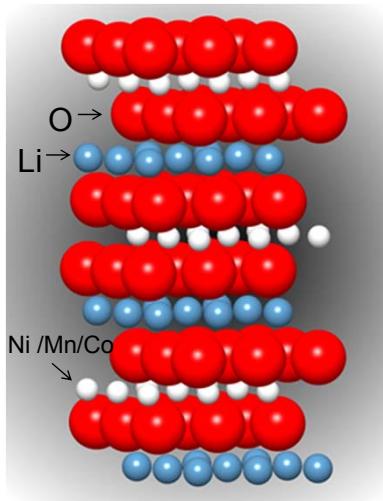


Selected results

Summary and outlook



## Layered structure – $\text{Li}(\text{Ni}_{1/3}\text{Mn}_{1/3}\text{Co}_{1/3})\text{O}_2$



### Structure and properties:

- Theoretical capacity: 290 mAh/g
- Voltage versus Li: 2.5 V – 4.3 V
- Space group:  $\overline{\text{R}3m}$   
hexagonal lattice  
 $a = b = 0.2867 \text{ nm}$   
 $c = 1.4246 \text{ nm}$   
 $\alpha = \beta = 90^\circ \gamma = 120^\circ$
- Layers of closed packed oxygen ions are separated by alternating layers of lithium and transition metal ions

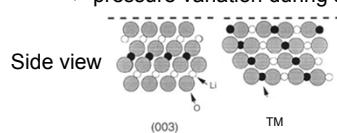
## Goals for materials development

Fabrication of Li-Ni-Mn-Co-O layered structure with high capacity and enhanced  $\text{Li}^+$  diffusion

- Nanocrystalline material with optimised chem. composition

### Optimization of grain orientation

- Variation of deposition and growth kinetics  
→ pressure variation during sputtering



Diffusion coefficients  $\text{Li}_{0.8}\text{CoO}_2$ :

(003) orientation:  $\sim 1 \times 10^{-14} \text{ cm}^2\text{s}^{-1}$   
(104) orientation:  $\sim 1 \times 10^{-12} \text{ cm}^2\text{s}^{-1}$

"Orientation dependence of Li-ion diffusion kinetics in  $\text{LiCoO}_2$  thin films prepared by RF magnetron sputtering" J. Xie, N. Imanishi, T. Matsumura, A. Hirano, Y. Takeda, O. Yamamoto, Solid State Ionics, 2008

Picture redesigned "Preferred Orientation of Polycrystalline  $\text{LiCoO}_2$  Films" J. B. Bates, N. J. Dudney, B. J. Neudecker, F. X. Hart, H. P. Jun, S. A. Hackney, Journal of The Electrochemical Society, 2000

- Increase of the crystallinity

- Heat treatment of the films ( $T = \text{const.}, t = \text{const.}$ )
- Influence pressure during heat treatment in  $\text{Ar}/\text{O}_2$  (80:20) atmosphere on crystallization process

## Characterisation Methods



- X-ray diffraction (XRD)
- Raman-spectroscopy
- Chemical analysis
  - Inductively coupled plasma optical emission spectrometry (ICP-OES)
  - Carrier gas hot extraction (CGHE)
- Electrochemical analysis
  - galvanostatic cycling

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## Experimental procedure 2-Step process

### Deposition conditions:

- Leybold Heraeus Z 550 PVD
- Argon - atmosphere (non reactive)

### Thin film constitution:

$\text{Li}(\text{Ni}-\text{Mn}-\text{Co})\text{O}_2$	1 – 1.5 $\mu\text{m}$
Si / SS	



### Deposition parameters:

- Power: RF 100 W
- Pressure: 0.2 ; 0.5 ; 2 ; 4 ; 7 ; 10 ; 20 Pa

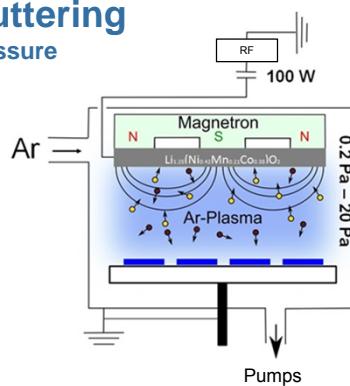
### Heat treatment:

- Temperature: 600 °C
- Atmosphere : Ar / O<sub>2</sub> (80:20)
- Pressure range: 10 mPa, 10 Pa, 150 Pa, 80 kPa
- Time: 1 h

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## 1. Step: Magnetron sputtering

Variation of argon working gas pressure

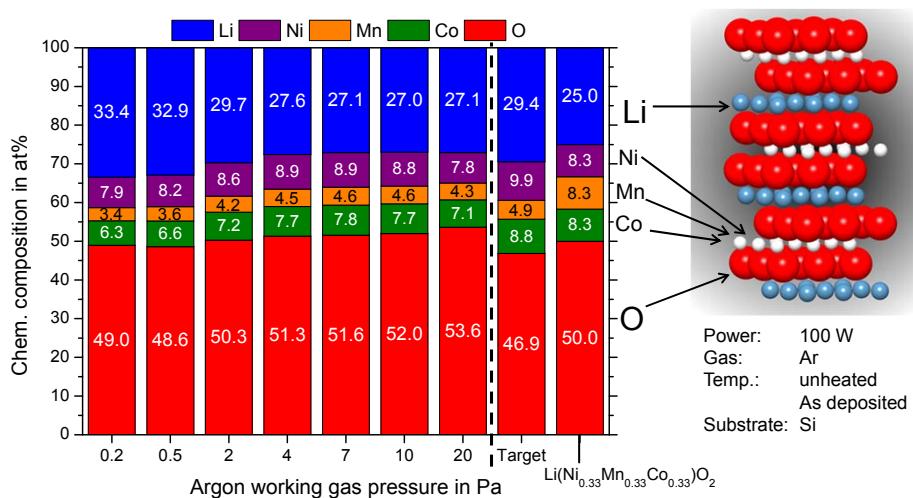


- Target: Li-Ni-Co-Mn-O (Li-rich)
- Power: RF 100 W
- Pressure range: 0.2 ; 0.5 ; 2 ; 4 ; 7 ; 10 ; 20 Pa
- Working gas: Ar
- Temperature: unheated (RT)
- Substrate: Si (001) / stainless steel

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## As deposited thin films

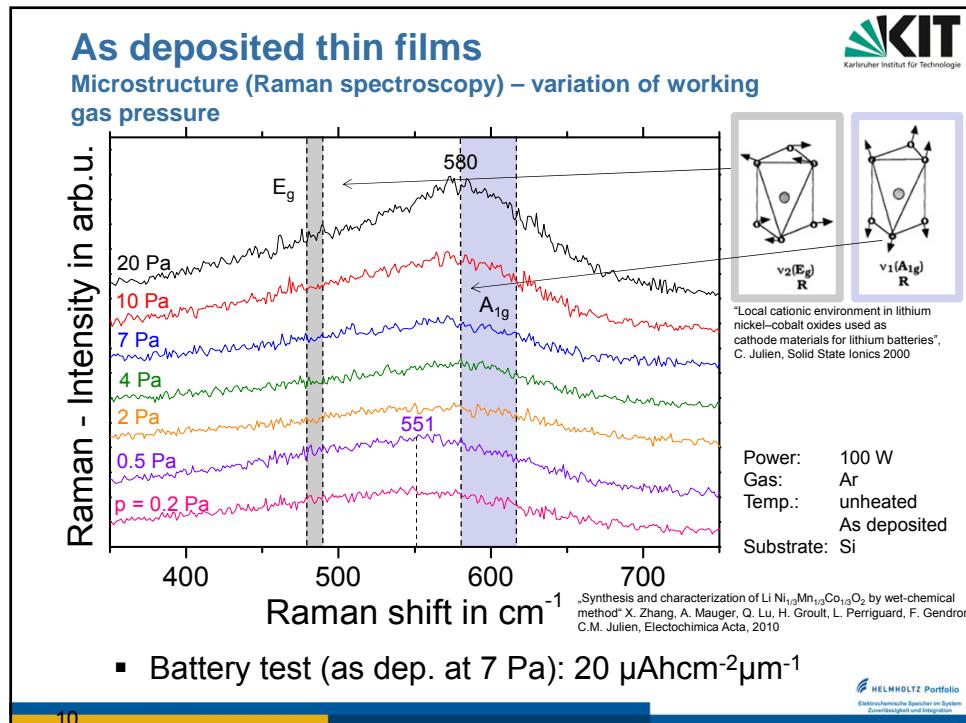
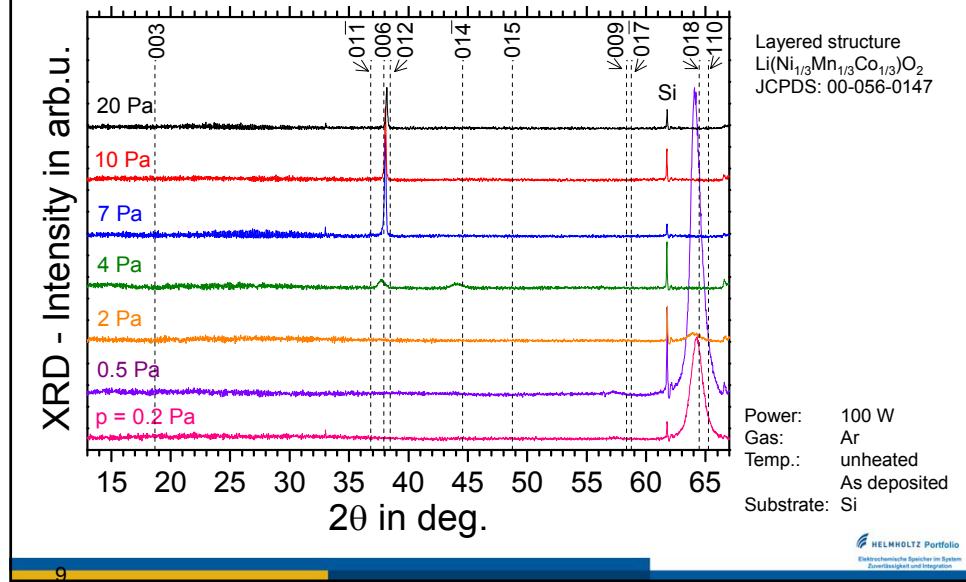
Chem. composition (ICP-OES / CHGE) – variation of working gas pressure



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## As deposited thin films

Microstructure (XRD) – variation of working gas pressure



## 2. Step: Heat treated thin films 7 Pa

Variation of heat treatment pressure

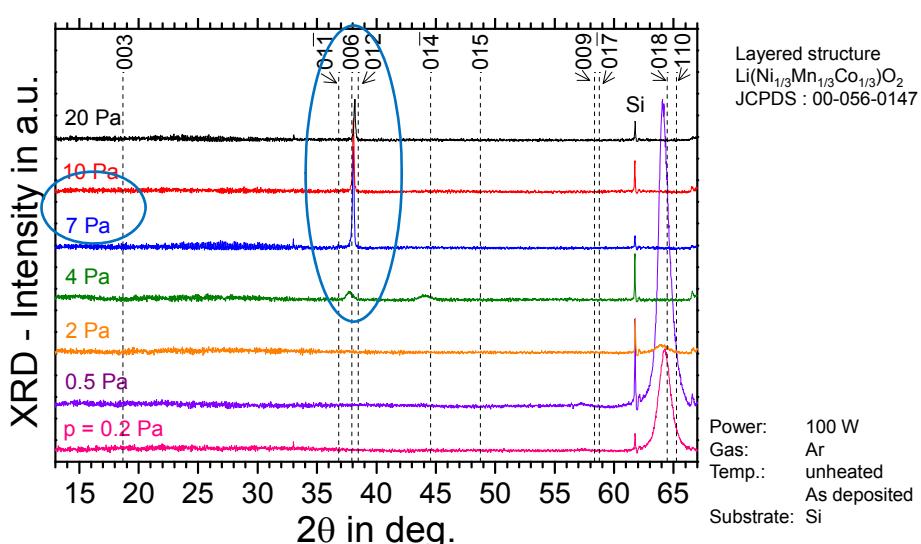


- Sample: Deposited at 7 Pa
- Temperature: 600 °C
- Atmosphere: Ar / O<sub>2</sub> (80 : 20)
- Pressure : 10 mPa, 10 Pa, 150 Pa, 80 kPa
- Time: 1 h
- Substrate: Stainless steel S 30400

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## As deposited thin films

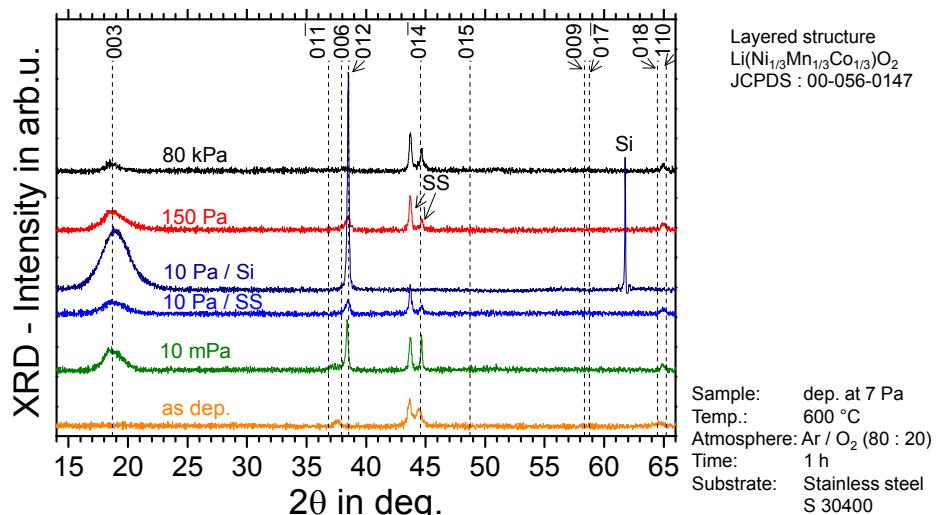
microstructure (XRD) – variation of working gas pressure



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## Heat treated thin films 7 Pa

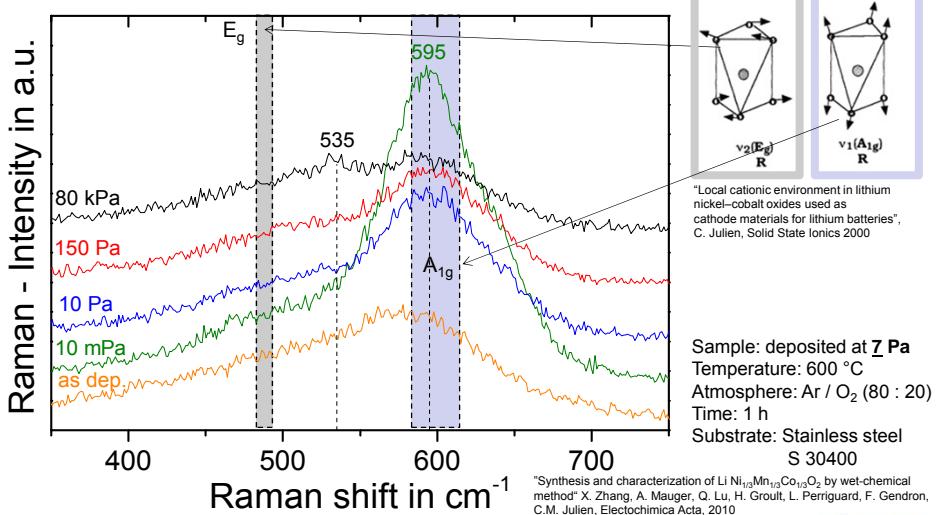
microstructure (XRD) – variation of heat treatment pressure



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## Heat treated thin films 7 Pa

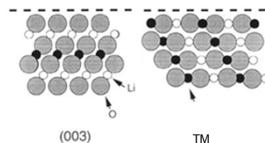
microstructure (Raman spectroscopy) - variation heat treatment pressure



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## Summary and Outlook

- Li-Ni-Mn-Co-O films were successfully deposited with different chemical compositions and microstructures
- As deposited unordered layer structure showed discharge capacity of about  $20 \mu\text{Ahcm}^{-2}\mu\text{m}^{-1}$   
Variation of Li and O concentration up to 5 at%
- Texture depending on pressure
  - 0.2 Pa – 2 Pa: (018) / (110)
  - 4 Pa – 20 Pa : (012)
- Pressure during post annealing has an influence on the crystallisation process
  - During heat treatment the structure transforms into an ordered layer structure
- Battery tests and investigation of heat treated films and development of a one step process to deposit ordered layer structure
- Deposition on structured substrates and structuring by different deposition methods



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- The members of the “Department for Composites and Thin Films” and IAM-AWP

You for your attention

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